

INFORMATION DISCLOSURE STATEMENT BY APPLICANT	ATTY. DOCKET NO. 2345/108	SERIAL NO. To be assigned
	APPLICANT Hans Wilfried Peter KOOPS <b>09/462283</b>	
	FILING DATE Herewith	GROUP <b>17A6</b> To be assigned

## U. S. PATENT DOCUMENTS

EXAMINER INITIAL	PATENT NUMBER	PATENT DATE	NAME	CLASS	SUBCLASS	FILING DATE
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## FOREIGN PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
						YES	NO
SA	196 16 324*	October 30, 1997	DE				
SA	0 614 126*	September 7, 1994	EP				
SA	63 249837*	October 17, 1988	JP				

\*Copy of Reference is not enclosed because reference is cited in Search Report (copy of reference provided by International Searching Authority).

## OTHER DOCUMENTS

EXAMINER INITIAL	AUTHOR, TITLE, DATE, PERTINENT PAGES, ETC.
SA	Ehrfeld et al., "Integrated Optics and Micro-Optics with Polymers," 1993, B.G. Teunber Verlag.*
SA	Brenner et al., "Deep Proton Irradiation of PMMA for a 3D Integration of Optical Components," pp. 159-176.* <b>1993</b>
SA	Eguchi et al., "Gradient Index Polymer Optical Waveguide Patterned by Ultraviolet Irradiation," Japanese Journal of Applied Physics, vol. 28, no. 12, part 02, December 1, 1989, pp. L 2232-2235.*
SA	Lazare et al., "Microlenses Fabricated by Ultraviolet Excimer Laser Irradiation of Poly(Methyl Methacrylate) Followed by Styrene Diffusion," Applied Optics, vol. 35, no. 22, August 1, 1996, pp. 4471-4475.*

\*Copy of Reference is not enclosed because reference is cited in Search Report (copy of reference provided by International Searching Authority).

EXAMINER	<i>Shamin Ahmed.</i>	DATE CONSIDERED	<i>7/24/01</i>
EXAMINER: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.			